

<b>Form 1449 (Modified)</b>  <b>Information Disclosure Statement By Applicant</b>  (Use Several Sheets if Necessary)	Atty. Docket No.	Application No.:
	HIT1P010/	10/617,908
	SJ09-2002-0123US1	
	Applicant:	
	Kim Y. Lee et al	
	Filing Date:	Group Art Unit:
	Herewith 07/10/2003	3729

#### U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
TN	A	6,219,207	4/17/01	Pinarbasi	360	322	4/26/99
TN	B	2001/0001256	5/17/01	Hsiao	360	246.6	1/16/01
TN	C	5,978,183	11/2/99	Hsiao et al.	360	113	12/11/97
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	F						
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	H						
	I						
	J						
	K						
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#### Foreign Patent or Published Foreign Patent Application

Examiner Initial	No.	Document No.	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
	M							
	N							
	O							
	P							

#### Other Documents

Examiner Initial	No.	Author, Title, Date, Place (e.g. Journal) of Publication
	R	
	S	
	T	
Examiner /Tai Nguyen/		Date Considered 05/12/2006

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

05/12/2006